



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 13, 2025	
IGI Report Number	LG754564241
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	8.34 X 8.05 X 5.35 MM

GRADING RESULTS

Carat Weight	3.51 CARATS
Color Grade	D
Clarity Grade	VS 2

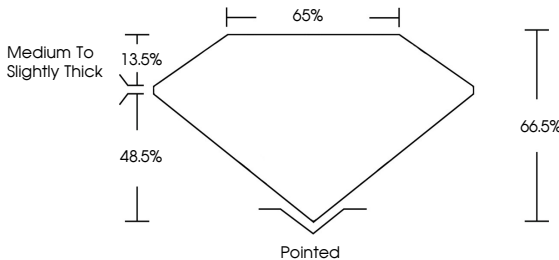
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG754564241

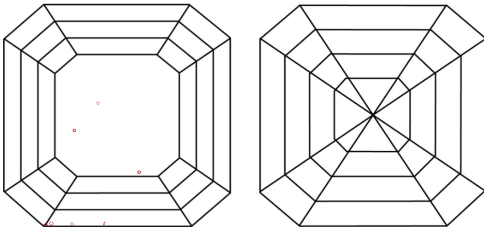
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG754564241
Report verification at igi.org

PROPORTIONS

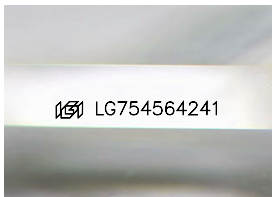


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

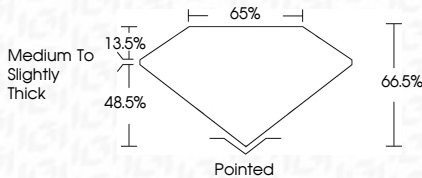
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IGI



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December 13, 2025
 IGI Report No LG754564241
 SQUARE EMERALD CUT

3.51 CARATS
D
VS 2
66.6%
65%
Medium To Slightly
Thick
Pointed
EXCELLENT
EXCELLENT
NONE
4691 G75454241

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(CVD) growth process.
Type IIa